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(Not for submission under 37 CFR 1.99)

Application Number		10587592				
Filing Date		2006-07-28				
First Named Inventor	Tomo	Tomomi MEGURO et al.				
Art Unit		1792				
Examiner Name	Talbot, Brian					
Attorney Docket Number		81844.0051				

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	2	Li et al. "Growth of High Quality ZnO Thin Films at Low Temperature on Si(100) Substrates by Plasma Enhanced Chemical Vapor Deposition" Journal of Vacuum Science and Technology: Part A AVS/AIP, Melville, Vol. 20, No. 1, 2002 Haga et al. "ZnO Thin Films Prepared by Remote Plasma-Enhanced CVD Method" Journal of Crystal Growth, Amsterdam, NL, Vol. 214-215, pp. 77-80, 2000								
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	4	European Search Report for corresponding European application 05709393.2-2122 lists the references above								
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